



PATENT APPLICATION **779**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q67810

Masashi ANDO, et al.

Appln. No.: 10/066,638

Group Art Unit: 1753

Confirmation No.: 6088

Examiner: OLSEN, KAJ K.

Filed: February 6, 2002

RECEIVED
AUG 20 2003
GROUP 1700

For: **METHODS AND APPARATUS FOR MEASURING NO_x GAS CONCENTRATION
FOR DETECTING EXHAUST GAS CONCENTRATION AND FOR
CALIBRATING AND CONTROLLING GAS SENSOR**

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §§ 1.97 and 1.98**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure under 37 C.F.R. § 1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the documents which are listed on the attached PTO/SB/08 A & B (modified) form and/or listed herein and which the Examiner may deem material to patentability of the claims of the above-identified application. One copy of each of the listed documents is submitted herewith.

The present Information Disclosure Statement is being filed after the later of three months from the application's filing date and the mailing date of the first Office Action on the merits, but before a Final Office Action, Notice of Allowance, or an action that otherwise closes prosecution in the application (whichever is earlier), and therefore Applicant is filing concurrently herewith a Statement Under 37 C.F.R. § 1.97(e). No fee under 37 C.F.R. § 1.17(p) is required.

The present Information Disclosure Statement is being filed thirty days or fewer from a communication from a foreign patent office in a counterpart foreign application, and a Statement Under 37 C.F.R. § 1.704(d) is attached. A copy of the communication from the foreign patent office is enclosed (Office Action of Japanese Patent Office issued July 28,

INFORMATION DISCLOSURE STATEMENT

U.S. Appln. No.: 10/066,638 (*Q67810*)

2003 in corresponding JP Appln. No. 10-223211, which claims priority from JP Appln. No. 9-224225).

In compliance with the concise explanation requirement under 37 C.F.R. § 1.98(a)(3) for foreign language documents, Applicant submits the following:


(1) for JP 10-073563 and JP 08-029387, English translations of the claims and the specification are attached;

(2) for JP 9-113484, JP 9-318597, JP 10-142194, and JP 10-221298, English abstracts are attached.

The communication from the foreign patent office lists JP 8-271467, which is already of record (via the February 6, 2002 IDS). Therefore, Applicant is not submitting JP 8-271467 at this time.

The submission of the listed documents is not intended as an admission that any such document constitutes prior art against the claims of the present application. Applicant does not waive any right to take any action that would be appropriate to antedate or otherwise remove any listed document as a competent reference against the claims of the present application.

Respectfully submitted,



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WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: August 19, 2003



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STATEMENT UNDER 37 C.F.R. § 1.97(e)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of said Information Disclosure Statement.

Respectfully submitted,

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Alexandria, VA 22313-1450

Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the undersigned after making a reasonable inquiry, that the communication was not received by any individual designated in 37 C.F.R. § 1.56(c) more than thirty days prior to the filing of said Information Disclosure Statement.

Respectfully submitted,


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